$$C_{\text{Int}}^{\pi \text{ MC}}(E_i) = \frac{N_{\text{Int}}^{\pi \text{ MC}}(E_i)}{N_{\text{Int}}^{\text{TOT MC}}(E_i)}$$
(1)

$$= \frac{N_{\text{Int}}^{\text{TOT MC}}(E_i) - B_{\text{Int}}^{\text{TOT MC}}(E_i)}{N_{\text{Int}}^{\text{TOT MC}}(E_i)}$$
(2)

$$C_{\text{Inc}}^{\pi \text{ MC}}(E_i) = \frac{N_{\text{Inc}}^{\pi \text{ MC}}(E_i)}{N_{\text{Inc}}^{\text{TOT MC}}(E_i)}$$
(3)

$$= \frac{N_{\text{Inc}}^{\text{TOT MC}}(E_i) - B_{\text{Inc}}^{\text{TOT MC}}(E_i)}{N_{\text{Inc}}^{\text{TOT MC}}(E_i)}$$
(4)

$$E_{\text{Front Face}}^{\text{kin}} = \sqrt{p_{Beam}^2 + m_{Beam}^2 - m_{Beam} - E_{Loss}}$$
 (5)

$$U_{i,j}^{\text{Int}}(E_i) \tag{6}$$

$$U_{i,j}^{\mathrm{Inc}}(E_i) \tag{7}$$

$$E_j^{\text{kin}} = E_{\text{Front Face}}^{\text{kin}} - \sum_{j < i} E_{\text{dep i}}$$
 (8)

$$E_i = \sqrt{p_{Beam}^2 + m_{Beam}^2} - m_{Beam} - E_{Loss} - E_{dep \text{ FF-j}}$$
(9)

$$E_{\text{slice j}} = \sqrt{p_{Beam}^2 + m_{Beam}^2 - m_{Beam} - E_{Loss} - E_{\text{dep FF-j}}}$$
 (10)

$$\delta E_{\text{slice j}} = \sqrt{\delta p_{Beam}^2 + \delta E_{Loss}^2 + \delta E_{\text{dep FF-j}}^2}$$
 (11)

	Low E Beam	High E Beam
G4Pions	70.9 %	82.3 %
G4Muons	14.6 %	13.5 %
G4Electrons	14.5 %	4.2 %

Table 1: Simulated beamline composition per magnet settings

$$E_{\text{dep FF-j}} = \sum_{j < s} E_{\text{dep s}} \Rightarrow \delta E_{\text{dep FF-j}} = (j-1)\delta E_{\text{dep s}}$$
(12)

$$\sigma_{TOT}^{\pi^{-}}(E_i) = \frac{1}{n \ \delta X} \frac{\epsilon^{\text{Inc}}(E_i) \ C_{\text{Int}}^{\pi MC}(E_i) \ N_{\text{Int}}^{\text{TOT}}(E_i)}{\epsilon^{\text{Int}}(E_i) \ C_{\text{Inc}}^{\pi MC}(E_i) \ N_{\text{Inc}}^{\text{TOT}}(E_i)}.$$
(13)

$$\sigma_{TOT}^{K^+}(E_i) = \frac{1}{n \ \delta X} \frac{\epsilon^{\text{Inc}}(E_i) \ C_{\text{Int}}^{KMC}(E_i) \ N_{\text{Int}}^{\text{TOT}}(E_i)}{\epsilon^{\text{Int}}(E_i) \ C_{\text{Inc}}^{KMC}(E_i) \ N_{\text{Inc}}^{\text{TOT}}(E_i)}.$$
 (14)

$$P_{\text{Int}} = \frac{N_{\text{Int}}}{N_{\text{Inc}}} = 1 - e^{-\sigma_{\text{TOT n }\delta X}}$$
(15)

$$\sigma_{\rm TOT}(E) \sim \frac{1}{\text{n }\delta X} \frac{N_{\rm Int}}{N_{\rm Inc}}$$
 (16)

$$\sigma_{\text{TOT}}(E_i) = \frac{1}{\text{n }\delta X} \frac{N_{\text{Int}}^{\pi^-}(E_i)}{N_{\text{Inc}}^{\pi^-}(E_i)}$$
(17)

$$\mathcal{L}(\mu_0; \sigma_0^2; \Delta\theta_0, \Delta\theta_1) = \prod_{i=0}^{1} f_X(\Delta\theta_i, \mu_0, \sigma_0^2) \Rightarrow$$
 (18)

$$\log \mathcal{L} = -\frac{1}{2}\log(2\pi) - \log\sigma_0 - \frac{1}{2}\frac{(\Delta\theta_0 - \mu_0)^2}{\sigma_0^2} + \text{same for } \Delta\theta_1$$
 (19)

	Run-II Neg Pol
1. Events Reconstructed in Beamline	158396
2. Events with Plausible Trajectory	147468
3. Beamline $\pi^-/\mu^-/e^-$ Candidate	138481
4. Events Surviving Pile Up Filter	108929
5. Events with WC2TPC Match	41757
6. Events Surviving Shower Filter	40841
7. Available Events For Cross Section	40841

Table 2: Number of data events for Run-II Negative and Positive polarity